



Patent

2812

Customer No.: 31561  
Application No.: 10/064,561  
Docket No. 9167-US-PA

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Applicant : Chang  
Application No. : 10/064,561  
Filed : July 26, 2002  
For : METHOD FOR FABRICATING RAISED SOURCE/DRAIN  
OF SEMICONDUCTOR DEVICE  
Art Unit : 2812  
Examiner : LINDSAY JR, WALTER LEE

**RESPONSE TO FIRST OFFICE ACTION**

ASSISTANT COMMISSIONER FOR PATENTS  
Arlington, VA22202

Dear Sirs, ,

In response to the Office Action, dated August 6, 2003, a Response was faxed to the assigned fax number (703-872-9318) on November 4, 2003. The complete response together with the fax confirmation report which prove a successful receipt of the correspondence are now being forwarded to the USPTO.

Enclosed please find:

- ☒ Amendment and Response to Office Action in (10) pages
- ☒ Fax confirmation report
- ☒ Prepaid return postcard
- ☐ Extension fee

Since the relevant paper in response to paper no. 3 was already submitted to the USPTO on the said date prior to the due date, I believe that no fee is incurred. However, the Commissioner is authorized to charge any fees required in connection with the filing of this paper to account No. 50-2620 (Order No.: 9486-US-PA)

Thank you for your assistance in the subject matter. If you have any questions, please feel free to contact me.

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Respectfully Submitted,  
JIANQ CHYUN Intellectual Property Office

Date: Nov. 11, 2003

By: Belinda Lee  
Belinda Lee  
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